

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

Confirm. No.: 1791

NAKAYAMA ET AL.

Atty. Ref.: 925-342

Serial No. 10/581,247

TC/A.U.: 2822

Filed: May 31, 2006

Examiner: Green, T.D.

For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND  
MANUFACTURING METHOD THEREFOR

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January 25, 2010

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

Responsive to the Official Action dated October 23, 2009, please amend the  
above-identified application as follows:

**Amendments to the Specification** begin on page 2.

**Remarks/Arguments** begin on page 3.